



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: §  
Buie, et al. §  
Serial No.: 10/024,958 §  
Confirmation No.: 3439 §  
Filed: December 18, 2001 §  
For: Etch Process for §  
Photolithographic Reticle §  
Manufacturing with §  
Improved Etch Bias §

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>April 19, 2005</u> , with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313- 1450.	
<u>April 19, 2005</u> Date	 Signature

Dear Sir:

### SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.



The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

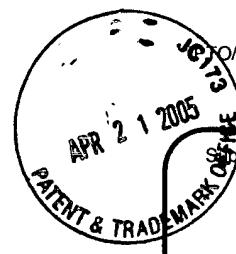
Applicants certify that all references submitted with this disclosure were first cited in a communication from a foreign patent office dated February 14, 2005, which communication is enclosed, not more than three months prior to the filing of this Supplemental Information Disclosure Statement.

If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/4213.P1/BKH.

Respectfully submitted,

  
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Brian K. Hrna  
Registration No. 41,852  
MOSER, PATTERSON & SHERIDAN, L.L.P.  
3040 Post Oak Blvd. Suite 1500  
Houston, TX 77056  
Telephone: (713) 623-4844  
Facsimile: (713) 623-4846  
Attorney for Applicant(s)

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**SUPPLEMENTAL INFORMATION  
DISCLOSURE STATEMENT BY  
APPLICANT**

**(Use as many sheets as necessary)**

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of 2

<i>Complete if Known</i>	
<i>Application Number</i>	10/024,958
<i>Filing Date</i>	DECEMBER 18, 2001
<i>First Named Inventor</i>	BUIE, ET AL.
<i>Art Unit</i>	1765
<i>Examiner Name</i>	KIN-CHAN CHEN
<i>Attorney Docket Number</i>	AMAT/4213.P1/MASK/MASK-ETCH/ARNOLD S

## **U.S. PATENT DOCUMENTS**

## FOREIGN PATENT DOCUMENTS

Examiner Signature		Date Considered	
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<sup>4</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>5</sup>Applicant's unique citation designation number (optional). <sup>6</sup>See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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(Use as many sheets as necessary)

Sheet

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of

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### Complete if Known

Application Number	10/024,958
Filing Date	DECEMBER 18, 2001
First Named Inventor	BUIE, ET AL.
Art Unit	1765
Examiner Name	KIN-CHAN CHEN
Attorney Docket Number	AMAT/4213.P1/MASK/MASK-ETCH/ARNOLD S

### NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	C1	PCT International Search Report dated February 14, 2005 for PCT/US2004/008335. (AMAT/7681PCT)	
	C2	PCT Written Opinion dated February 14, 2005 for PCT/US2004/008335. (AMAT/7681PCT)	
	C3	Mohri, et al., "Manufacturing of Half-Tone Phase Shift Masks: I. Blank" Proceedings of the SPIE – The International Society for Optical Engineering USA, Vol. 2254, 1994, pages 238-247	
	C4	Miyashita, et al., "Manufacturing of Half-Tone Phase Shift Masks: II. Writing and Process", Proceedings of the SPIE – The International Society for Optical Engineering USA, Vol. 2254, 1994, pages 248-260. (AMAT/7681CPT)	

Examiner Signature	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.

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